

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	)	
Fumitsugu FUKUYO et al.	)	Confirmation No.: 1798
	)	
Application No.: 10/507,392	)	Group Art Unit: 2892
	)	
Filed: April 8, 2005	)	Examiner: Elias Ullah
	)	
For: LASER PROCESSING METHOD	)	

Commissioner for Patents  
U.S. Patent and Trademark Office  
**Customer Window, Mail Stop RCE**  
Alexandria, VA 22314

Sir:

**AMENDMENT UNDER 37 C.F.R. § 1.116**

In response to the final Office Action dated May 27, 2009, and pursuant to 37 C.F.R. § 1.116, the period for response to which is extended through Monday, September 28, 2009 with the concurrently filed Petition for a One-Month Extension of Time, please amend the above-identified application as follows: